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Class	Subclass	
31	106	

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U.S. REISSUE Patent Application

O.I.P.E.	O.G. PUBLICATION DATE	REISSUE PATENT DATE
SCANNED  Q.A. 	6/1/15	

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
10/066747	D F	034	404	3749	O'Malley Wilson, Paul

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Vacuum processing and operating method
and for Semiconductors

PTO-2040
12/99

FPAW 8/31/03

SURRENDER OF ORIGINAL PATENT

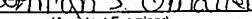
Exr. Initials)

ORIGINAL PATENT NUMBER

,330,755

ISSUING CLASSIFICATION

Continued on Issue Slip Inside File Jacket

TERMINAL DISCLAIMER		DRAWINGS			CLAIMS ALLOWED	
		Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
<input type="checkbox"/> The term of this patent subsequent to _____ (date) has been disclaimed.		1	2	1	32)
		NOTICE OF ALLOWANCE MAILED				
		<p><i>Kathleen S. O'Malley 5/25/04</i></p> <p>(Assistant Examiner) (Date)</p>				
		 <p>Jennifer Lazarus Supervisory Patent Examiner Group 2700 GJL (Primary Examiner) (Date)</p>				
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